

INFORMATION DISCLOSURE CITATION FORM FOR PATENT APPLICATION (FORM PTO-1449) (Substitute)			Docket No.: YOR920030190US1 Serial No.: 10/815,103 Applicant(s): Keith E. FOGEL et al. Filing Date: 3/31/2004 Group: 2826			
U.S. PATENTS						
Initials	Patent Number	Issue Date	Name	Class	Sub-class	Filing date
<i>de</i> 	4,835,593	5/1989	Arnold et al.			
	5,162,257	11/1992	Yung			
	5,937,320	8/1999	Andricacos			
	5,767,010	6/1998	Mis et al.			
	5,244,143	9/1993	Ference et al.			
	5,775,569	7/1998	Berger et al.			
	6,003,757	12/1999	Beaumont			
	6,056,191	5/2000	Brouillette et al.			
FOREIGN PATENT DOCUMENTS						
Initials	Document Number	Date	Country	Name	Translation? Yes/No/n/a	
OTHER DOCUMENTS (Title, Author, Date, Pages, Etc., if known)						
<i>de</i>	Datta et al., Electrochemical Fabrication of Mechanically Robust PbSn C4 Interconnections, J. Electrochem. Soc., 142, 3779 (1995)					
Examiner's Signature: <i>[Signature]</i>				Date Considered: <i>[Signature]</i>		
Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).						